

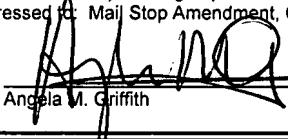


IFW

Docket No.: H0498.70217US02
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Lieber, et al.
Serial No.: 10/588,833
Confirmation No.: 4453
Filed: August 9, 2006
For: NANOSTRUCTURES CONTAINING METAL SEMICONDUCTOR
COMPOUNDS
Examiner: Not Yet Assigned
Art Unit: 2667

Certificate of Mailing Under 37 CFR 1.8(a)	
I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as First Class Mail, in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.	
Dated: 7/30/07	 Angela M. Griffith

TRANSMITTAL LETTER

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Enclosed are the following items for filing in connection with the above-referenced Patent Application:

1. Preliminary Amendment;
2. Information Disclosure Statement
3. Application Data Sheet
4. Return Receipt Postcard

The Director is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 23/2825, under Docket No. H0498.70217US02. A duplicate copy of this paper is enclosed.

Dated: 07/30/07

Respectfully submitted,

By 

Timothy J. Oyer, Ph.D.

Registration No.: 36,628

Tani Chen, Sc.D.

Registration No.: 52,728

WOLF, GREENFIELD & SACKS, P.C.

Federal Reserve Plaza

600 Atlantic Avenue

Boston, Massachusetts 02210-2206

(617) 646-8000